



Industrial Consultancy & Sponsored Research (IC&SR)

# AAO TEMPLATE-ASSISTED SYNTHESIS PROCESS COUPLED WITH ALKALI ETCHING TO DEVELOP ZINC OXIDE BRANCHED SUPERSTRUCTURES IITM Technology Available for Licensing

# **Problem Statement**

- In the prior arts, patent and non patent literature, there are few processes discussed for production of zinc oxide superstructures which incur high initial equipment cost & requires modifiers, seed layers, or surface directing agents which can compromise the purity of the developed nanostructures.
- Further, the above prior art techniques require variety of organic or inorganic ingredients with time-consuming processing steps, including heat treatment. Hence, there is a requirement of a simple process to address the above issues efficiently.

## Technology Category/ Market

**Technology:** Zinc Oxide branched superstructures

**Industry:** Chemical, Renewable energy, Pharmaceutical

**Applications:** Catalysis, Sensing, Electronics **Market:** The global nano zinc oxide market was valued at \$0.3 billion in 2021, projected to reach **\$1.1 billion** by **2031**, growing at a CAGR of **13.2%** from **2022** to **2031**.

#### Technology

- Patent literature talks about a process of preparation of zinc oxide (ZnO) superstructures by coupling anodic aluminum oxide (AAO) template-assisted synthesis with alkali etching, wherein the process comprises a steps of,
- **Electropolishing ultrasonically** cleaned aluminium strips;
- Conducting first anodization for 1 hour;
- Oxide etching at 60°C for 1 hour;
- Conducting second anodization for 2 hours;
- Thinning the alumina dielectric barrier layer by sequentially reducing the anodization voltage;

# CONTACT US

**Dr. Dara Ajay,** Head Technology Transfer Office, IPM Cell- IC&SR, IIT Madras

IITM TTO Website: https://ipm.icsr.in/ipm/

- Etching the sample in 5 wt. % phosphoric acid at 20°C for 45 min to widen the pores;
- Electrochemical deposition of zinc oxide (ZnO) nanowires within the AAO nanochannels;
- Hydroxide etching of ZnO nanowires embedded in the AAO template to obtain ZnO superstructures.
- Further, talks about various features for obtaining ZnO superstructure shown in smart chart:

The Electropolishing step is done at 20V DC, at 10°C for 60s including a mixture of perchloric acid & ethanol in 1:4 v/v ratio.

First & second anodization steps are conducted in an electrolyte of 0.3M oxalic acid solution at 20°C with a constant voltage of 45V DC.

In the hydroxide etching step, the nanowires are etched further for a period of 0 to 60 minutes under concentration range of 0.5 to 2M NaOH at a temperature between 5 to 50°C.

 In this instant, the process of obtaining ZnO superstructure along with outcomes are depicted in the figures.

## Intellectual Property

IITM IDF Ref. 2249; IN Patent No: 421576 (Granted)

TRL (Technology Readiness Level)

TRL- 4, Proof of Concept ready & validated

#### **Research Lab**

**Prof. Lakshman Neelakantan, Prof. Parasuraman Swaminathan** Dept. of Metallurgical & Materials Engineering, IIT Madras

Email: smipm-icsr@icsrpis.iitm.ac.in

sm-marketing@imail.iitm.ac.in

Phone: +91-44-2257 9756/ 9719



IIT MADRAS Technology Transfer Office TTO - IPM Cell



Industrial Consultancy & Sponsored Research (IC&SR)

# AAO TEMPLATE-ASSISTED SYNTHESIS PROCESS COUPLED WITH ALKALI ETCHING TO DEVELOP ZINC OXIDE BRANCHED SUPERSTRUCTURES IITM Technology Available for Licensing

Key Features / Value Proposition

#### \* Technical Perspective:

Indian Institute of Technology Madras

1. Claimed Patent provides simple fabrication process to develop zinc oxide (ZnO) superstructures, by coupling anodic aluminum oxide template-assisted synthesis with alkali etching.

### \* Industrial Perspective:

1.Patented Process is cost-effective, less time taking, scalable technique to grow zinc oxide (ZnO) SSs with file tunable morphologies and modifier/catalysts/seed layers free.



Fig. 1: Illustrates a schematic representation of the series of steps involved in the development of ZnO SSs through AAO template assisted technique coupled with alkali etching;



Figs. 2a & 2b: Illustrate zinc oxide SSs developed just after AAO template dissolution during alkali etching at room temperature;

### **CONTACT US**

**Obtained ZnO** superstructure

Dr. Dara Ajay, Head Technology Transfer Office, IPM Cell- IC&SR, IIT Madras

IITM TTO Website: https://ipm.icsr.in/ipm/

Email: smipm-icsr@icsrpis.iitm.ac.in sm-marketing@imail.iitm.ac.in Phone: +91-44-2257 9756/ 9719